

THE INFLUENCE OF THE SURFACE OPTICAL PROPERTIES MODIFICATION ON ABSORPTION OF LASER RADIATION

HRUŠKA Matěj, TESAŘ Jiří, VOSTŘÁK Marek, SMAZALOVÁ Eva

University of West Bohemia, Pilsen, Czech Republic, EU, maslej@ntc.zcu.cz

Abstract

This study examines the relation between surface condition and its response to interaction with a laser. The surface character is modified by the creation of oxide layer. The oxide layers were created by solid state pulsed laser that is mostly used for industrial marking. The relation was tested on samples with a different width of created oxide layer. The modified samples were processed by diode laser used for surface treatment (primarily hardening). The surface temperature was measured during this experiment. The surface hardness and hardness depth profile was measured for all samples. The effect of pretreatment on hardness and microstructure will be discussed. The goal of the work is to find out optimal parameters for creation of the oxide layer that cause sufficient modification of optical properties to make the required laser absorption rise possible.

Keywords: Oxide layer, diode laser, optical properties, laser interaction, treated surface

1. INTRODUCTION

Laser hardening is the modern technology of improving surface properties of the metallic materials. The material is rapidly heated to a high temperature by guiding the laser beam across the workpiece surface. Short interaction period of the laser beam and the processed surface cause, that the absorbed energy is concentrated only at the irradiated surface area, whereas the core remains cold. The rapid removal of heat from the surface layer to the colder unaffected bulk of a processed part allows the formation of a required microstructure. The used laser hardening technology is explained in [1].

The depth of hardened layer is dependent on absorbed energy. Dependence of hardened depth on various coatings was described in [2]. The relation between measured surface temperature and laser absorption was emphasized in this paper. An infrared camera was used in [3] for process characterization, control, and temperature field monitoring. ThermaCAM SC3000 was applied to temperature fields measurements during hardening of a cylinder in [4]. The view of the camera was at an angle of 30° with respect to the laser beam. The emissivity was set to the value of 0.88, corresponding to the applied surface coating, which was used to improve absorptivity. The same camera but at an angle of 53° was used in [5]. The emissivity of the sample was estimated during the heating with the propane torch in order to see how emissivity changes with temperature.

It is obvious that laser hardening is very closely connected with the surface condition because it can radically influence the absorption of a laser radiation. The absorption of the laser beam can be changed by modification of the optical properties of the irradiated sample surface. The modification can be achieved by pulsed laser processing. This method allows controlled growth of oxide layer. This phenomenon is described in detail in [6].

The incident, reflected, absorbed, and transmitted fluxes are connected together by energy conservation law. From this fact can be deduced that the sum of optical properties reflectivity (ρ), absorptivity (α), and transmissivity (τ) equals one [7]:

$$\rho + \alpha + \tau = 1 \quad (1)$$

For an opaque object without transmission ($\tau = 0$) the relation (1) simplifies

$$\rho + \alpha = 1 \tag{2}$$

Kirchhoff's law provides a relation between the absorption and emission processes and thus between emissivity and absorptivity

$$\varepsilon = \alpha \tag{3}$$

These relations are valid for similar spectral or total spectral condition. In this case, there are three sets of optical properties (three different wavelengths) for that Kirchhoff's law, is valid. The three wavelengths are the wavelength of engraving laser 1064 nm, the wavelength of hardening laser 808 nm, and the measuring range of infrared cameras 7.5 - 14 μm , eventually 1 μm . This means that, for example, the emissivity of the surface in the range of infrared camera ε_{IR} has no direct connection with absorptivity on the wavelength of hardening laser α_{HPDD} .

2. EXPERIMENTAL PROCEDURE

2.1. Surface modification - laser marking system

Tests were performed on a sample from steel C45 with dimension 100 x 100 x 25 mm. Oxide layers of square dimension 7 x 7 mm were created by marking laser SPI-G3-SP-20P with MOPA arrangement according to **Figure 1**. Parameters, to heating but not remelting the surface, were chosen. The scanning speed of the laser beam and laser power were chosen common for all samples. The power was set to 17.25 W and the value of 800 mm/s was selected for scanning velocity. The depth of the oxide layer depends on energy E_v brought into the treated area. The quantity of the input energy was controlled by hatch density and allows operated growth of oxide layer. It means that it is controlled by the value of l_s distance between laser crossings. The manner of heating the treated surface layer by the laser is featured in **Figure 2**. 24 different oxide layers were made overall.

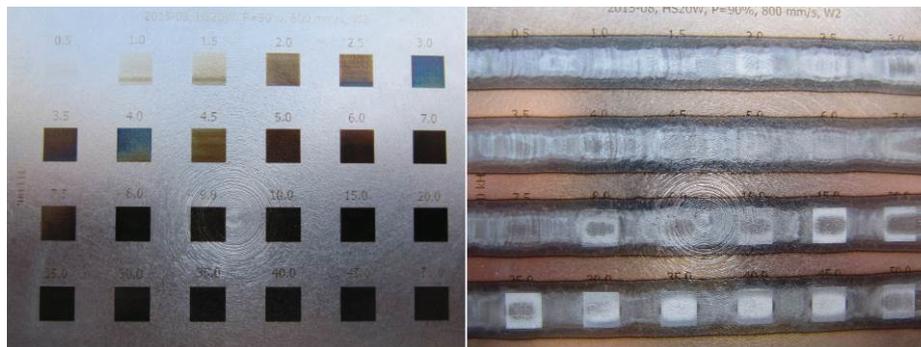


Figure 1 Sample after treating by marking laser (on the left), after consecutive processing by HPDD laser (on the right)

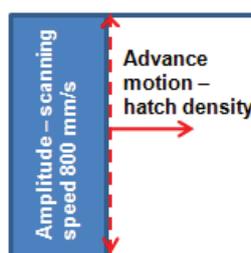


Figure 2 Technology of creating oxide layer by laser beam

2.2. Laser hardening process

The sample with treated squares undergoes consequently laser hardening with continuous HPDD (High Power Direct Diode) laser Coherent Highlight ISL - 4000L. The laser head is set on industrial manipulator Fanuc M710iC (**Figure 3**). Laser emits at wavelength 808 nm and its maximal power is 4.3 kW. The laser spot has a rectangular shape with dimension 12 x 6 mm, Gaussian energetic distribution in the 6 mm long side direction and uniform energetic distribution in the other side direction. The laser beam with a power of 2 kW and traversing speed of 1.2 m/min was applied for processing of treated sample. The process was observed by three IR cameras (**Figure 3**).

The thermo-vision MSC640 was mounted on laser head to move with a laser beam. The camera measures emitted infrared radiation on the wavelengths around 1 μm (780 - 1080 nm) and had set temperature measurement range 673 - 1530°C. The thermo-visions Flir A615 and Variocam HD were set on tripods and these measures in the wavelength range 7.5 - 14 μm . The A615 camera has set temperature measurement range 100 - 650°C and the Variocam used 250 - 2000°C. The thermo-cameras measured with recording frequency 10 Hz. Measured values from the MSC640 were used for the evaluation, values from the other cameras have rather an informational character due to high emissivity dependence.



Figure 3 Experimental arrangement

3. RESULTS AND DISCUSSION

3.1. Temperature measurement and post-processing

The temperature was measured directly in laser spot during the hardening process. Temperature values were evaluated in LenaSense LumaSpec RT software the values were got by analyzing value at one point placed in the middle of the laser spot and the comparable value was obtained by averaging measured values from a whole laser spot area. The measurement by the MSC640 is significantly less dependent on the emissivity of the measured surface then using LWIR (Long Wave Infra Red) cameras because it measures infrared radiation on the wavelengths around 1 μm . The measurement accuracy of the thermo-vision is $\pm 0.5\%$ of measured value.

The measured surface temperatures are shown in **Table 1**. One crossing of the sample by the laser beam is noted in **Figure 4**. Six variants of oxide layers with different width were overridden by the laser beam during this one crossing. The temperatures displayed in **Figure 4** were measured for six different oxide layers created by laser heating with brought energy E_v from 25 to 50 J/mm². It is evident from **Figure 4**, that temperature

measured on basic non-treated material flow maximally to 1200°C, the temperatures measured on treated areas flow along 1450 - 1650°C. It shows that the surface absorptivity of the material was seriously increased.

Table 1 Maximal temperatures - T_{max} and values obtained by averaging - T_{av} in relation to brought energy E_v (width of oxide layer), T_{max} , T_{av} (**Figure 4**) for non-treated surface flow along 1150 - 1200°C

| | | | | | | | | | | | | |
|----------------------------|------|------|------|------|------|------|------|------|------|------|------|------|
| E_v [J/mm ²] | 0.5 | 1 | 1.5 | 2 | 2.5 | 3 | 3.5 | 4 | 4.5 | 5 | 6 | 7 |
| T_{max} [°C] | 1058 | 1097 | 1139 | 1206 | 1214 | 1256 | 1231 | 1238 | 1252 | 1267 | 1270 | 1307 |
| T_{av} [°C] | 1034 | 1076 | 1118 | 1191 | 1199 | 1253 | 1216 | 1229 | 1235 | 1260 | 1255 | 1305 |
| E_v [J/mm ²] | 7.5 | 8 | 9 | 10 | 15 | 20 | 25 | 30 | 35 | 40 | 45 | 50 |
| T_{max} [°C] | 1238 | 1303 | 1306 | 1327 | 1327 | 1389 | 1471 | 1442 | 1458 | 1451 | 1565 | 1643 |
| T_{av} [°C] | 1220 | 1274 | 1290 | 1292 | 1323 | 1376 | 1395 | 1405 | 1425 | 1428 | 1465 | 1583 |

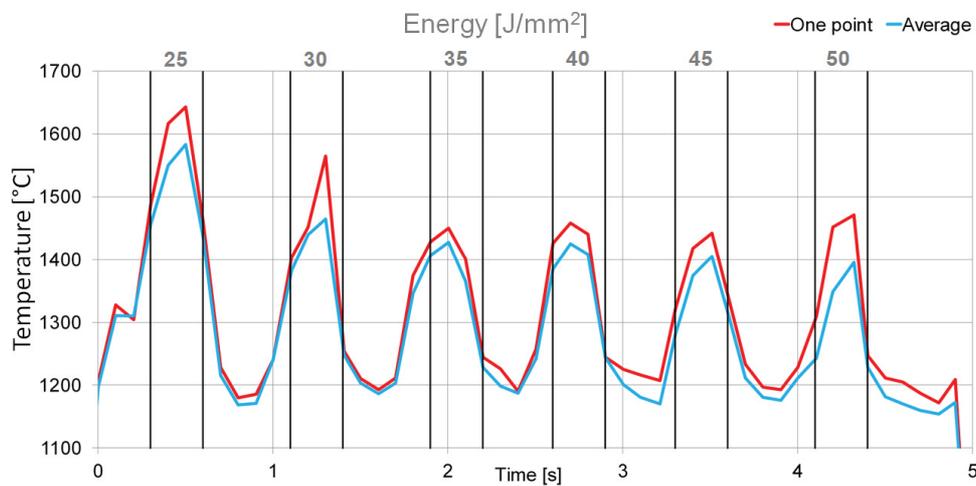


Figure 4 Compare - Temperature value analyzed from one point in the middle of the laser spot (red), Temperature value got by averaging measured values from a whole laser spot area (blue)

3.2. Microstructure properties

Surface hardness and hardness depth profile were measured. The results in **Tables 1, 2** implicate the relation between measured surface temperature and laser absorption that affects properties like surface hardness and hardness depth. Higher surface temperature means higher laser absorption and higher laser absorption results in higher hardness depth. The surface temperature for laser hardening process has to exceed value 1050°C for C45 material to cause microstructure transformation and to assure the creation of required martensitic structure. Surface hardness decreases with the further gradual increase of surface temperature. It is caused by a decline in heat dissipation from the surface layer.

Table 2 Hardness measured 150 μm under the surface H_{150} and hardness depth profile H_D , for untreated surface $H_{150UN}=595$ HV1, $H_{DUN}=400$ μm

| | | | | | | | | | | | | |
|----------------------------|-----|-----|-----|-----|-----|-----|-----|-----|-----|-----|-----|-----|
| E_v [J/mm ²] | 0.5 | 1 | 1.5 | 2 | 2.5 | 3 | 3.5 | 4 | 4.5 | 5 | 6 | 7 |
| H_{150} [HV1] | 522 | 590 | 510 | 607 | 710 | 721 | 691 | 695 | 559 | 587 | 659 | 623 |
| H_D [μm] | 300 | 350 | 350 | 500 | 400 | 400 | 500 | 500 | 500 | 600 | 550 | 600 |
| E_v [J/mm ²] | 7.5 | 8 | 9 | 10 | 15 | 20 | 25 | 30 | 35 | 40 | 45 | 50 |
| H_{150} [HV1] | 710 | 678 | 649 | 620 | 706 | 637 | 710 | 713 | 675 | 702 | 774 | 683 |
| H_D [μm] | 550 | 600 | 650 | 600 | 500 | 500 | 550 | 500 | 650 | 650 | 600 | 700 |

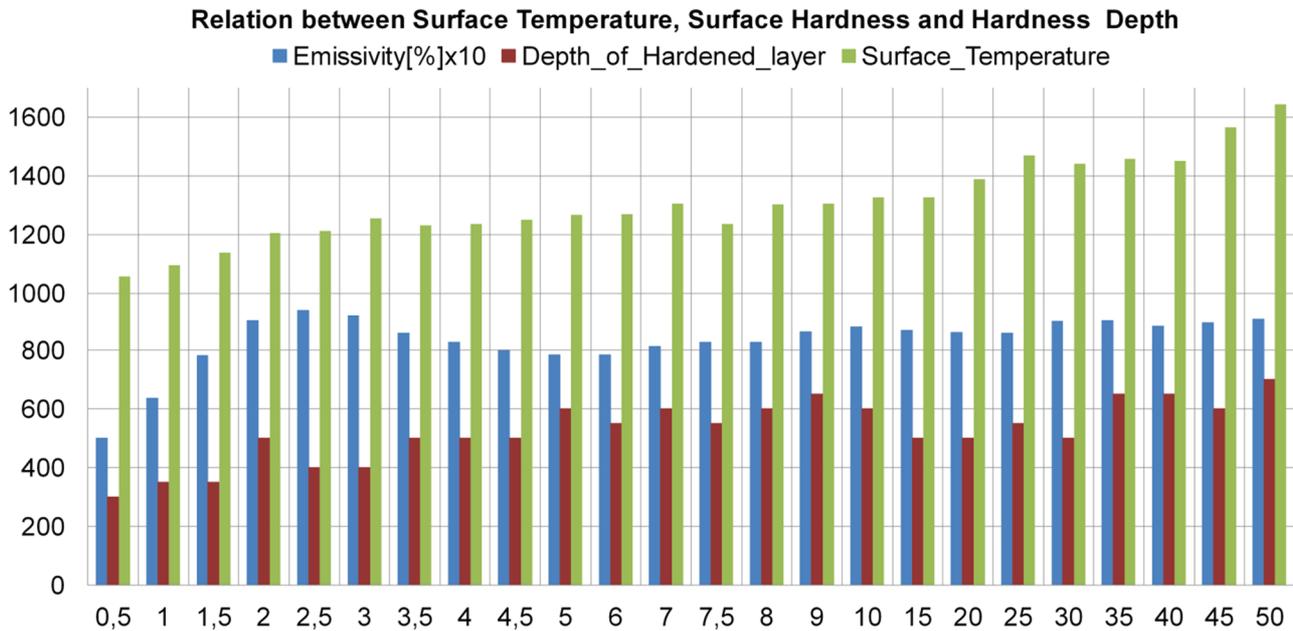


Figure 5 Compare of measured Hardness, Depth of hardened layer and Surface Temperature

The achieved depth of hardened layer depends on the surface emissivity. Notice that growing surface temperature results in increasing depth of the hardened layer of the irradiated surface. This upward trend can be seen in **Figure 5**. The difference in the depth of hardened layer between the untreated surface and the treated area with the highest depth is around 300 μm . This result proves that the emissivity was seriously increased. The surface hardness of treated area was increased too.

This paper proves that thermal surface modification can seriously change absorptivity, resulting in the influence of the created hardened layer parameters.

4. CONCLUSION

The paper is focused on characterization of the relation between the surface absorptivity and its effect on the absorption of laser radiation during the hardening process. The absorptivity influences the surface temperature, measured during the process, and consequently parameters of formed hardened layer. The surface absorptivity can be changed by the creation of oxide layer. The width of the oxide layer depends on “brought energy”. “Brought energy” is input energy brought into the processed part. This input energy can be very precisely driven into the surface by using the IR laser beam and precious deflection system (scanning head). Higher input energy results in a higher depth of oxide layer and thicker oxide layer causes higher absorption of laser radiation. This paper proved that the surface modification has a serious influence on the absorption of near-IR laser radiation.

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